



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Mamoru NAKASUJI et al.**

Group Art Unit: **2881**

Application Number: **09/891,511**

Examiner: **Jack I. Berman**

Filed: **June 27, 2001**

Confirmation Number: **8779**

For: **INSPECTION SYSTEM BY CHARGED PARTICLE BEAM AND METHOD OF  
MANUFACTURING DEVICES USING THE SYSTEM**

Attorney Docket Number: **010819**

Customer Number: **38834**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

August 11, 2006

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated April 20, 2006 for one month from July 20, 2006 to August 20, 2006.

Attached please find a check in the amount of \$120.00 for the cost of the extension. If any additional fees are due in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

**WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP**

  
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Enclosures: Check  
RCE Transmittal